



US005790574A

United States Patent [19]**Rieger et al.**[11] **Patent Number:** **5,790,574**[45] **Date of Patent:** ***Aug. 4, 1998**[54] **LOW COST, HIGH AVERAGE POWER, HIGH BRIGHTNESS SOLID STATE LASER**[75] Inventors: **Harry Rieger; Henry Shields**, both of San Diego; **Richard M. Foster**, Manhattan Beach, all of Calif.[73] Assignee: **IMAR Technology Company**, San Diego, Calif.

[*] Notice: The term of this patent shall not extend beyond the expiration date of Pat. No. 5,934,875.

[21] Appl. No.: **845,185**[22] Filed: **Apr. 21, 1997****Related U.S. Application Data**

[63] Continuation of Ser. No. 503,373, Jul. 17, 1995, abandoned, which is a continuation-in-part of Ser. No. 295,283, Aug. 24, 1994, Pat. No. 5,434,875, Ser. No. 339,755, Nov. 15, 1994, Pat. No. 5,491,707, and Ser. No. 429,589, Apr. 27, 1995, abandoned.

[51] Int. Cl.⁶ **H01S 3/10**[52] U.S. Cl. **372/25; 372/18; 372/12; 372/13; 372/22; 372/30; 372/31; 372/70**[58] Field of Search **372/25, 18, 12, 372/13, 22, 31, 30, 70, 75, 69**[56] **References Cited****U.S. PATENT DOCUMENTS**

5,434,875 7/1995 Rieger et al. 372/25

Primary Examiner—Leon Scott, Jr.
Attorney, Agent, or Firm—John R. Ross[57] **ABSTRACT**

A high average power, high brightness solid state laser system. We first produce a seed laser beam with a short pulse duration. A laser amplifier amplifies the seed beam to produce an amplified pulse laser beam which is tightly focused to produce pulses with brightness levels in excess of 10^{11} Watts/cm². Preferred embodiments produce an amplified pulse laser beam having an average power in the range of 1 kW, an average pulse frequency of 12,000 pulses per second with pulses having brightness levels in excess of 10^{14} Watts/cm² at a 20 μ m diameter spot which may be steered rapidly to simulate a larger spot size. Alternately, a kHz system with several (for example, seven) beams (from amplifiers arranged in parallel) can each be focused to 20 μ m and clustered to create effective spot sizes of 100 to 200 μ m. These beams are useful in producing X-ray sources for lithography.

34 Claims, 10 Drawing Sheets